## **Experiment setup**



<u> /////</u>

Outside

circuit

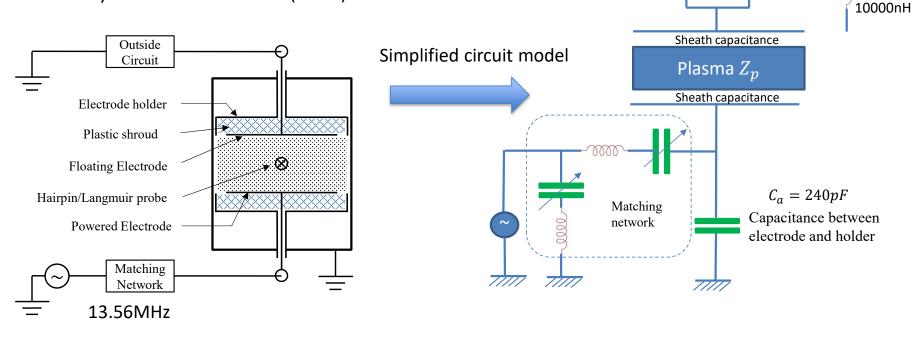
 $C_b = 240 pF$ 

Capacitance between

electrode and holder

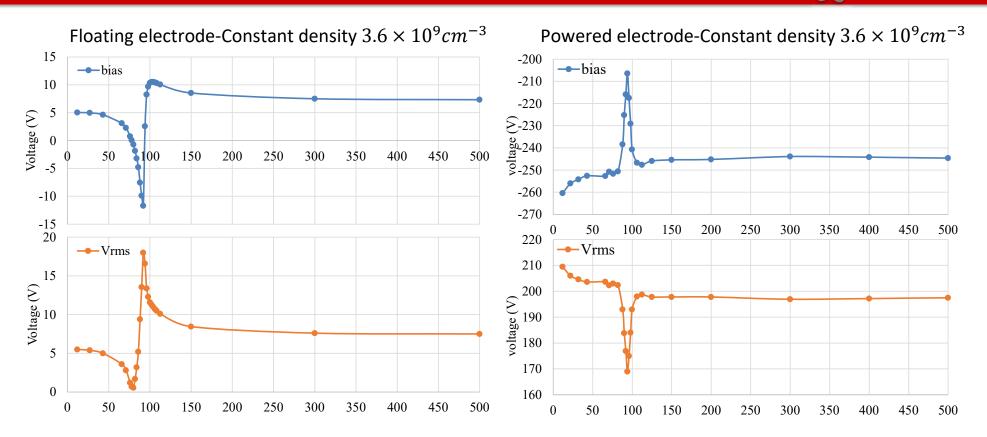
12~500pF

- Electron density  $n_e$  is measured by hairpin probe
- Plasma potential  $V_p$  and  $T_e$  are taken by Langmuir probe
- A V/I probe is connected to the bottom electrode, measuring root mean square RF voltage  $V_{rms}$
- A retarding field energy analyzer (RFEA) is mounted on the bottom electrode, which gives the DC self-bias of the electrode and ion velocity distribution functions (IVDFs).



## Analysis of constant density cases – 20mTorr Argon

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- DC self-bias of powered electrode can be increased by 20%
- DC self-bias of floating electrode can be decreased by 200% (from 10V to -10V)
- Sheath of floating electrode shares more delivered power at resonance.